Patent

Case No.: 58392US002

First Named Inventor:

FAN, XUDONG

Application No.:

10/685208

Confirmation No.:

4078

Filed:

October 14, 2003

Title:

POROUS MICROSPHERE RESONATORS

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop: Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 CERTIFICATE OF MAILING OR TRANSMISSION [37 CFR § 1.8(a)]

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Dear Sir:

Pursuant to 37 CFR §§ 1.56, 1.97, and 1.98, enclosed is a completed Form PTO-1449, citing references submitted for consideration by the Examiner. It is respectfully requested that the Examiner initial and return the enclosed Form PTO-1449 to indicate that each reference has been considered.

Copies of any cited foreign patents, foreign publications, non-patent literature documents, and any pending U.S. applications filed before June 30, 2003, are enclosed. Copies of any pending U.S. applications filed after June 30, 2003 that can be accessed on the USPTO's IFW system are not enclosed as per USPTO Waiver dated September 21, 2004. Copies of any U.S. patents and published U.S. patent applications are not enclosed.

This Information Disclosure Statement is being mailed after receipt of a first Office Action on the merits, but prior to the mailing of a Notice of Allowance under 37 CFR § 1.311.

Fees:

One copy of this sheet marked duplicate is also enclosed.
☐ Any required fee will be paid at the time of EFS-Web submission.
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Respectfully submitted,

2)-0cm/006

Date

William D. Miller, Reg/No.: 37,988

Telephone No.: 651-733-6649

Office of Intellectual Property Counsel
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Substitute for form 1449A/PTO (modified)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

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Attorney Case Number	58392US002

U.S. Patent Documents						
Exam.	Cite	Document Number	Publication Date	Name of Patentee	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
Init.*	No.	Doc. Number-(Kind Code if Known)	MM-DD-YYYY	or Applicant of Cited Document		
-	A1	US- 6,865,317	03/08/2005	Vahala et al.		
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	A12	US-				

	Foreign Patent Documents							
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		Ctry. Code	Number-KindCode (If known)	MM-DD-YYYY	Applicant of Cited Document	or Relevant Figures Appear	(Check if yes)	
	B1							
	B2							
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	B4							
	B5							

	OTHER DOCUMENTS							
Exam. Cite Init.* No.		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published						
	C1	CHAN, S., et al. "Porous Silicon Microcavities for Biosensing Applications," <i>Physical Status Solid</i> , Vol. 182, (2000) pp. 541-546.						
	C2	DE STEFANO, L., et al., "Optical Sensing of Flammable Substances Using Porous Silicon Microcavities," <i>Materials Science and Engineering</i> , Vol. 100, July 25, 2003, pp. 271-274.						
	C3	MULLONI, V., et al. "Porous Silicon Microcavities as Optical Chemical Sensors," <i>Applied Physics Letters</i> , Vol. 76, No. 18, May 1, 2000, pp. 2523-2525.						

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